	Application No.	Applicant(s)
Notice of Allowability	00/939 693	DELCED ET AL
	09/838,683 Examiner	BELSER ET AL. Art Unit
	At A. It. Store of	0054
	Natalia Figueroa	2651
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to 10 August 2004.		
2. The allowed claim(s) is/are 1,2 and 4-25.		
3. The drawings filed on 29 March 2004 are accepted by the Examiner.		
4.		
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview Summary Paper No./Mail Da 8), 7. Examiner's Amend	te

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Jesus Del Castillo (Reg. No. 51,604) on January 14, 2005.

The application has been amended as follows:

RE claim 9, delete "The method of claim 3", replace with - The method of claim 2 -.

Allowable Subject Matter

- 2. Claims 1-2 and 4-25 allowed.
- 3. The following is an examiner's statement of reasons for allowance:

RE claim 1, the prior art of record, and in particular Kikitsu et al (USPN 6,602,620), fails to teach or suggest a method comprising the step of changing the magnetic properties of portions of the recording layer by exposing the mask and the exposed portions of the recording layer to a plasma, wherein the magnetic properties of at least one layer in the exposed portions of the recording layer are changed, in order to create recordable regions or non-recordable regions in the recording layer.

RE claim 14, the prior art of record, and in particular Kikitsu et al (USPN 6,602,620), fails to teach or suggest a system comprising the means for changing the magnetic properties of portions of the recording layer by exposing the mask and the exposed portions of the recording layer to a plasma, wherein the magnetic properties of at least one layer in the exposed portions of

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the recording layer are changed, in order to create recordable regions or non-recordable regions in the recording layer.

4. Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Conclusion

5. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Natalia Figueroa whose telephone number is (703) 305-1260.

The examiner can normally be reached on Monday - Thursday 8:30-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Sinh N. Tran can be reached on (703) 305-4040. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

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system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

NFM

DAVID HUDSPETH SUPERVISORY PATENT EXAMINER

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